



Docket No.: SON-3163  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Tomiji Tanaka et al.

Application No.: 10/579,903

Confirmation No.: 6919

Filed: November 15, 2006

Art Unit: 2828

For: EXTERNAL CAVITY TYPE  
SEMICONDUCTOR LASER

Examiner: Michael W. Carter

**AMENDMENT SUBMITTED WITH REQUEST FOR CONTINUED EXAMINATION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Final Office Action dated June 4, 2008, and in conjunction with the Request for Continued Examination concurrently filed herewith, Applicant respectfully requests reconsideration of the above-identified U.S. patent application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.